

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Fukuda et al. ) Group Art Unit Unknown  
App. No. : Unknown )  
Filed : Herewith )  
For : A SEMICONDUCTOR- )  
PROCESSING DEVICE )  
PROVIDED WITH A REMOTE )  
PLASMA SOURCE FOR SELF- )  
CLEANING )  
Examiner : Unknown )

# 2

JC972 U.S. PTO  
09/764523  
01/18/01

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Enclosed is form PTO-1449 listing references that are also enclosed. This Information Disclosure Statement is being filed within three months of the filing date of this application, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: January 18, 2001

By: Adeel S. Akhtar

Adeel S. Akhtar  
Registration No. 41,349  
Attorney of Record  
620 Newport Center Drive  
Sixteenth Floor  
Newport Beach, CA 92660  
(415) 954-4114